

**AMENDMENTS TO THE SPECIFICATION:**

*Please replace paragraph [0048] with the following amended paragraph:*

**[0048]**        The pixel electrode 10 is formed in such a way that it overlaps the adjacent scanning lines 4 and signal lines 5 to thereby secure a sufficient area of an opening through which light passes, without using a light-shielding film. In the first embodiment, a slit ~~[[44]]~~ 14 is formed in a predetermined pattern in the auxiliary capacitor electrode 8 by removing a part of the auxiliary capacitor electrode 8 located above a scanning line 4 and a signal line 5 running along two adjoining sides of the pixel electrode 10 making a corner therebetween at a rubbing penetration side (Fig. 1 shows a direction 15 in which the rubbing treatment of matrix board 3 progresses.) of the matrix board 3.